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INFORMATION DISCLOSURE STATEMENT  
(Use several sheets if necessary)

Atty. Docket No. 20063/10001	Serial No. 10/606,693
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Applicant Jang et al.
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## U.S. PATENT DOCUMENTS

*EXAMINER INITIALS		DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
BK		U.S. 6,500,692	12-31-02	Methods of Making Thrench Photosensor for a CMOS Imager	438	73	02-14-01
BK		U.S. 6,177,333	01-23-01	Method for Making a Thench Isolation for Semiconductor Devices	438	433	
BK		U.S. 6,372,603	04-16-02	Photodiode with Thightly-Controlled Junction Profile For CMOS Image Sensor with STI Process	438	424	07-07-00

## FOREIGN PATENT DOCUMENTS

*Examiner Initials		Document Number	Publication Date	Country	Class	Subclass	Translation Yes      No

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)


EXAMINER <i>Broon Kebell</i>	DATE CONSIDERED <i>9/29/2004</i>
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	